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CONFIRMATION NO. 2224

<b>SERIAL NUMBER</b> 10/795,994	<b>FILING or 371(c) DATE</b> 03/10/2004 <b>RULE</b>	<b>CLASS</b> 257	<b>GROUP ART UNIT</b> 2826	<b>ATTORNEY DOCKET NO.</b> KAW 110D1	
<b>APPLICANTS</b> Kazutaka Shibata, Kyoto-shi, JAPAN; <b>** CONTINUING DATA *****</b> This application is a DIV of 10/088,163 03/15/2002 PAT 6,734,556 which is a 371 of PCT/J01/06143 07/16/2001 <b>** FOREIGN APPLICATIONS *****</b> JAPAN 2000-216298 07/17/2000 JAPAN 2000-326926 10/23/2000 JAPAN 2001-12648 01/22/2001 JAPAN 2001-21113 01/30/2001 <b>** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **</b> 05/26/2004					
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and /BENJAMIN P SANDVIK/ Acknowledged Examiner's Signature		<input type="checkbox"/> Met after Allowance <b>STATE OR COUNTRY</b> JAPAN	<b>SHEETS DRAWINGS</b> 9	<b>TOTAL CLAIMS</b> 6	<b>INDEPENDENT CLAIMS</b> 2
<b>ADDRESS</b> Steven M. Rabin Rabin & Berdo, P.C. 1101 14th Street, N.W., Suite 500 Washington, DC 20005 UNITED STATES					
<b>TITLE</b> Semiconductor device and method for manufacturing the same					
<b>FILING FEE RECEIVED</b> 770	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit		